

**CERTIFICATE OF ELECTRONIC
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I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1765, via EFS-WEB, on December 26, 2007.

<u>/David H. Brinkman/</u>	<u>12/26/07</u>
David H. Brinkman, Reg. No. 40,532	Date

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Martin Hausner
Serial No.:	10/524,525
Filed:	August 18, 2005
Confirmation No.:	1134
Group Art Unit:	1765
Examiner:	Ahmed, Shamim
Title:	METHOD FOR SELECTIVELY REMOVING MATERIAL FROM THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR A WAFER, AND WAFER WITH MASKING MATERIAL
Atty. Docket:	BEET-09

Cincinnati, Ohio 45202

December 26, 2007

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AFTER FINAL RESPONSE

In response to the Final Office Action mailed on September 26, 2007,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.